



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kobayashi, T. Higaku

Serial No.: 10/060,569

Filed: January 29, 2002

Title: METHOD OF FABRICATING A
SEMICONDUCTOR DEVICE

Attorney Docket No.: N230500C1

Group Art Unit: 1763

Examiner: Goudreau, G.

Hill
3/22/03
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RESPONSE TO FINAL OFFICE ACTION

Assistant Commissioner for Patents
BOX AF
Washington, D.C. 20231

Dear Sir:

The following is submitted in response to the Final Office Action dated January 13, 2003,
the two month Advisory Action Period ends March 13, 2003.

Entry of the following amendments is respectfully requested.

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37 C.F.R. §1.8

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Patents, Washington, D.C. 20231.

Date of Deposit: March 12, 2003

Typed/Printed Name: Darryl Walker

Signature: Dal Wan